



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Schroeder, et al. Docket No.: 00P9111 US  
Serial No.: 09/745,676 Art Unit: 2851  
Filed: December 21, 2000 Examiner: Rodney E. Fuller  
For: Method and Apparatus for Aerial Image Improvement in Projection  
Lithography Using a Phase Shifting Aperture

**Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))**

Date of Deposit: October 26, 2004

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Respectfully submitted,

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